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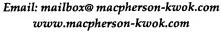
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February 27, 2006

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Re:

Applicants:

Chunyuan Chao, Kuei-Chang Tsai and George A. Kovall

Assignee:

Mosel Vitelic, Inc.

Title:

DYNAMICALLY CONTROLLABLE REDUCTION OF VERTICAL CONTACT DIAMETER THROUGH ADJUSTMENT OF ETCH MASK

STACK FOR DIELECTRIC ETCH

Application No.:

10/718,320

Filed:

November 19, 2003

Examiner:

Deo, Duy Vu Nguyen

Group Art:

1765

Docket No.:

M-15208 US

Confirmation No.:

1058

#### Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Return Receipt Postcard;
- (2) This Transmittal Letter (1 page in duplicate); and
- (3) Amendment (17 pages).

No additional fee is required.

The fee has been calculated as shown below:

#### **CLAIMS AS AMENDED**

		Claims Remaining After Amendment		Highest No. Previously <u>Paid For</u>		Present Extra		<u>Rate</u>		Additional Fee
Total	Claims	30	Minus	37	=	0	x	\$50.00	\$	0.00
Indepe		2	Minus	4	=	0	х	\$200.00	\$	0.00
	Fee of for the first filing of one or more multiple dependent claims per application								\$	
		Request for Extension							\$	0.00
Total additional fee for this Amendment:									\$	
Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.										
$\boxtimes$	Please charge our Deposit Account No. 50-2257 in the amount of								\$	0.00
Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 50-2257										
							1	Total:	\$	<u>0.00</u>

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on February 27, 2006.

Attorney for Applicant(s)

2-27-2006

Date of Signature

Respectfully submitted,

Gideon Gimlan Attorney for Applicants Reg. No. 31,955



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Chunyuan ("Luis") Chao et al

Assignee:

Mosel-Vitelic, Inc.

Title:

Dynamically Controllable Reduction of Vertical Contact Diameter

Through Adjustment of Etch Mask Stack for Dielectric Etch

Application No.:

10/718,320

Filing Date:

11/19/2003

Examiner:

Deo, Duy Vu Nguyen

Group Art Unit:

1765

Docket No.:

M-15208-US

Confirm No.:

1058

San Jose, California Monday February 27, 2006

COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA, VA 22313-1450

### **AMENDMENT**

Dear Sir:

In response to the Office Action having a mailing date of November 25, 2005, please amend the application as set forth below.

Amendment to Specification begins on page 2 of this paper.

Claims Listing begins on page 3 of this paper.

Remarks begin on page 9\_ of this paper.

**Application No.: 10/718,320** 

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